

IDS/#3

FORM PTO,1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		ATTY DOCKET NO. <div style="text-align: center; font-weight: bold;">35C.14179</div> APPLICATION NO. <div style="text-align: center; font-weight: bold;">09/722,454</div>	
		APPLICANT <div style="font-weight: bold; font-size: 1.2em;">YOUICHI ANDO, ET AL.</div>	
		FILING DATE <div style="text-align: center; font-weight: bold;">November 28, 2000</div>	GROUP <div style="text-align: center; font-weight: bold;">Unassigned</div>

  

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>Wmz</i>	5066883	11/91	Yoshioka, et al.	313	309	
<i>Wmz</i>	5528108	6/96	Cisneros	315	169.3	
<i>Wmz</i>	5569974	10/96	Morikawa, et al.	313	310	
<i>Wmz</i>	5682085	10/97	Suzuki, et al.	315	169.1	

  

FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
<i>Wmz</i>	EP, 0660357	6/95	Europe	—	—	
<i>Wmz</i>	EP, 1-31332	2/89	Japan	—	—	Abstract
<i>Wmz</i>	JP, 2-257551	10/90	Japan	—	—	Abstract
<i>Wmz</i>	JP, 3-55738	3/91	Japan	—	—	Abstract and USP 5,569,974
<i>Wmz</i>	JP, 4-28137	1/92	Japan	—	—	Abstract and USP 5,692,085
<i>Wmz</i>	JP, 7-235255	9/95	Japan	—	—	Abstract and EPA 660357
<i>Wmz</i>	JP, 8-106847	6/97	Japan	—	—	Abstract and USP 5,528,108

  

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
<i>Wmz</i>	Meyer, et al.; "Recent Development on 'Microtips' Display At Leti"; Tech. Dig. of IVMC 91, Nagahama 1991, pp. 6-9.
<i>Wmz</i>	Hartwell, et al.; "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films"; Tech. Dig. 1 EDM, Tech. Pig., Dec. 1-3, 1975, Wash. D.C., pp. 519-521 (1976).
<i>Wmz</i>	Spindt, et al.; "Physical Properties Of Thin-Film Field Emission Cathodes With Molybdenum Cones"; J. Appl. Phys. Vol. 47, No. 12, Dec. 1976, pp. 5248-5263.
<i>Wmz</i>	C.A. Mead; "Operation Of Tunnel-Emission Devices"; J. Appl. Phys. Vol. 32, No. 4, April 1961, pp. 646-652.
<i>Wmz</i>	Elinson, et al.; "The Emission Of Hot Electrons And The Field Emission Of Electrons From Tin Oxide"; Radio Engineering and Electronic Physics, Vol. 10, pp. 1290-1296, (1965).

  

EXAMINER <i>Manuel Martinez</i>	DATE CONSIDERED <i>9/23/03</i>
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

IDS/#3

<b>FORM PTO-1449 (modified)</b>  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		ATTY DOCKET NO. <b>35C.14179</b>		APPLICATION NO. <b>09/722,454</b>			
		APPLICANT <b>YOUICHI ANDO, ET AL.</b>					
		FILING DATE <b>November 28, 2000</b>		GROUP <b>Unassigned</b>			
<b>U.S. PATENT DOCUMENTS</b>							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
<b>OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
msjg	o	<b>G. Dittmer, "Electrical Conduction And Electron Emission Of Discontinuous Thin Films"; Thin Solid Films, Vol. 9, pp. 317-328 (1972).</b>					
msjg	i	<b>Dyke, et al., "Field Emission", Advances in Electronics and Electron Physics, Vol. III, Academic Press, 89-184 (1956).</b>					
msjg	d	<b>Araki, et al., "Electroforming and Electron Emission of Carbon Thin Films"; J. Vac. Soc. Japan, Vol. 26, No. 1, pp. 22-29 (1981).</b>					
EXAMINER <i>Marialy pml:ag</i>		DATE CONSIDERED <i>9/23/03</i>					

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

IDS/#5

FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

LIST OF REFERENCES CITED BY APPLICANT(S)  
(Use several sheets if necessary)

ATTY DOCKET NO.

35C.14179

APPLICATION NO.

09/722,454

APPLICANT

YOUICHI ANDO, ET AL.

FILING DATE

November 28, 2000

GROUP

2879

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>msky</i>		High Voltage Technology", Electric Institute, Ohm Company, pages 38, 39 (1981).

EXAMINER

*Manichs Pontiago*

DATE CONSIDERED

9/23/03

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Sheet 1 of 1